

GP 1763



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Mehdi Balooch et al	Docket No. :	IL-9940B
Serial No. :	09/636,134	Art Unit :	1763
Filed :	August 10, 2000	Examiner	R. Bueker
For :	Apparatus For Depositing A Low Works Function Material		

SB
7/12/01
MwCERTIFICATE OF MAILING UNDER 37 CFR 1.8(a)I hereby certify that the *attached* correspondence comprising:

1. Amendment (4 pages)
Attachment 1: Version with Markings to Show Changes Made (1 page)
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AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action mailed January 18, 2001 and April 3, 2001,
kindly amend the above identified application as follows:

In the Claims:

Claim 19, amend to read as follows:

19. (Amended) An apparatus for depositing a low work function material
on a substrate by laser ablation using short-wavelength photons, including:
- a deposition chamber,
 - a target containing low work function material in said chamber,

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